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AF/1714 IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **OKADA, Katsuhiko et al.**

Group Art Unit: 1714

Serial No.: 09/926,632

Examiner: **Tae H. Yoon**

Filed: **November 27, 2001**

**P.T.O. Confirmation No.: 2956**

For: **PRODUCTION METHOD FOR POWDER COATING, POWDER COATING AND  
PAINT FILM FORMATION METHOD**

**RESPONSE UNDER 37 CFR §1.116**  
**- EXPEDITED RESPONSE -**  
**GROUP ART UNIT 1714**

**MAILSTOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 25, 2004

Sir:

In response to the Office Action dated **May 26, 2004**, please amend the above-identified application as follows: